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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Hirofumi TAKIKAWA, et al.

SERIAL NUMBER: 09/989,024

GROUP: 2814

FILED: November 21, 2001

EXAMINER: RAO, SHRINIVAS H

FOR: METHOD FOR MANUFACTURING NANO-TUBE, NANO-TUBE  
MANUFACTURED THEREBY, APPARATUS FOR MANUFACTURING NANO-  
TUBE, METHOD FOR PATTERNING NANO-TUBE, NANO-TUBE MATERIAL  
PATTERNED THEREBY, AND ELECTRON EMISSION SOURCE

**REQUEST TO CORRECT TITLE OF INVENTION**

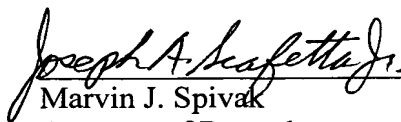
MAIL STOP ISSUE FEE  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application for patent, we hereby request  
correction of your records to reflect the correct title of the invention. The title of the  
invention should read as follows: METHOD FOR MANUFACTURING NANO-TUBE,  
NANO-TUBE MANUFACTURED THEREBY, APPARATUS FOR MANUFACTURING  
NANO-TUBE, METHOD FOR PATTERNING NANO-TUBE, NANO-TUBE MATERIAL  
PATTERNED THEREBY, AND ELECTRON EMISSION SOURCE.

Respectfully submitted,

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(OSMMN 08/03)